

IDS 7/30/04

ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18

Stylesheet Version v18.0

Title of Invention	CHEMICAL TREATMENT TO RETARD DIFFUSION IN A SEMICONDUCTOR OVERLAYER
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Application Number : *10/710,737*

Confirmation Number:

First Named Applicant: Kevin Chan

Attorney Docket Number: FIS920040027

Art Unit: *2822*

Examiner: *K. Duong*

Search string: (5731626 or 5967794 or 6043139 or 6271551).pn

US Patent Documents

Note: Applicant is not required to submit a paper copy of cited US Patent Documents

init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
<i>KD</i>	1	5731626	1998-03-24	Eaglesham et al.			
	2	5967794	1999-10-19	Kodama			
	3	6043139	2000-03-28	Eaglesham et al.			
✓	4	6271551	2001-08-07	Schmitz et al.			

Signature

Examiner Name <i>Johanh Duong</i>	Date <i>9/30/2005</i>
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